



ELECTRONIC COPY

LG758523991
Report verification at igi.org



December 20, 2025
IGI Report Number **LG758523991**
Description **LABORATORY GROWN DIAMOND**
Shape and Cutting Style **OVAL BRILLIANT**
Measurements **10.46 X 7.31 X 4.41 MM**
GRADING RESULTS
Carat Weight **2.08 CARATS**
Color Grade **F**
Clarity Grade **VVS 2**

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GRADING RESULTS

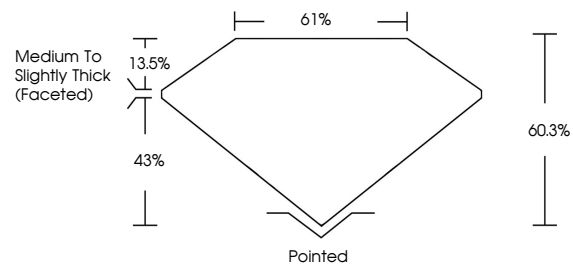
Carat Weight **2.08 CARATS**
Color Grade **F**
Clarity Grade **VVS 2**

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**
Symmetry **EXCELLENT**
Fluorescence **NONE**
Inscription(s) **IGI LG758523991**

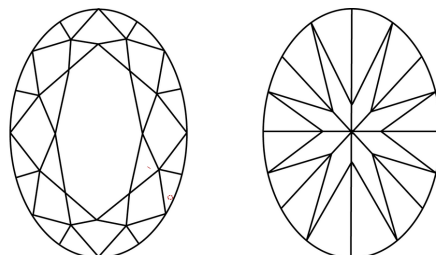
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

PROPORTIONS



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

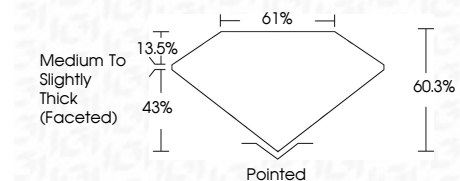
Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

| FL | IF | VVS ¹⁻² | VS ¹⁻² | SI ¹⁻² | I ¹⁻³ |
|----------|---------------------|-----------------------------|------------------------|-------------------|------------------|
| Flawless | Internally Flawless | Very Very Slightly Included | Very Slightly Included | Slightly Included | Included |



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IGI



December 20, 2025
IGI Report No LG758523991
OVAL BRILLIANT
10.46 X 7.31 X 4.41 MM
2.08 CARATS
Color Grade **F**
Clarity Grade **VVS 2**
Table **61%**
Depth **43%**
Girdle **Medium to Slightly Thick (Faceted)**
Culet **Pointed**
Polish **EXCELLENT**
Symmetry **EXCELLENT**
Fluorescence **NONE**
Inscription(s) **IGI LG758523991**
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